

technical stewardship. Rather, EDA's single-step application will make www.grants.gov a single access point for eligible applicants to electronically find and apply for its competitive grant opportunities.

This information collection is necessary to determine the applicant's eligibility for investment assistance under EDA's authorizing statute, the Public Works and Economic Development Act of 1965, as amended (42 U.S.C. 3121 *et seq.*), and regulations (13 CFR Chapter III); the quality of the proposed scope of work to address the pressing economic distress of the region in which the proposed project will be located; the merits of the activities for which the investment assistance is requested; and the ability of the eligible applicant to carry out the proposed activities successfully.

II. Method of Collection

Paper or electronically.

III. Data

OMB Number: 0610-0094.

Form Number: EDA-900A.

Type of Review: Regular submission.

Affected Public: State and local governments; Indian tribes; institutions of higher education; non-profit institutions; business or other for-profit organizations; individuals or households.

Estimated Number of Respondents: 875.

Estimated Time Per Response: 40 hours (current burden for forms ED-900P and ED-900A is 46 hours).

Estimated Total Annual Burden Hours: 35,000.

Estimated Total Annual Cost to Public: \$0.

IV. Request for Comments

Comments are invited on: (a) Whether the proposed collection of information is necessary for the proper performance of the functions of the agency, including whether the information shall have practical utility; (b) the accuracy of the agency's estimate of the burden (including hours and cost) of the proposed collection of information; (c) ways to enhance the quality, utility, and clarity of the information to be collected; and (d) ways to minimize the burden of the collection of information on respondents, including through the use of automated collection techniques or other forms of information technology.

Comments submitted in response to this notice will be summarized and/or included in the request for OMB approval of this information collection; they also will become a matter of public record.

Dated: April 19, 2007.

Gwellnar Banks,

Management Analyst, Office of the Chief Information Officer.

[FR Doc. E7-7832 Filed 4-24-07; 8:45 am]

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DEPARTMENT OF COMMERCE

International Trade Administration

Applications for Duty-Free Entry of Scientific Instruments

Pursuant to Section 6(c) of the Educational, Scientific and Cultural Materials Importation Act of 1966 (Pub. L. 89-651, as amended by Pub. L. 106-36; 80 Stat. 897; 15 CFR part 301), we invite comments on the question of whether instruments of equivalent scientific value, for the purposes for which the instruments shown below are intended to be used, are being manufactured in the United States.

Comments must comply with 15 CFR 301.5(a)(3) and (4) of the regulations and be filed within 20 days with the Statutory Import Programs Staff, U.S. Department of Commerce. Applications may be examined between 8:30 a.m. and 5 p.m. in room 2104, U.S. Department of Commerce, 14th and Constitution Avenue NW., Washington, DC 20230.

Docket Number: 07-014. *Applicant:* U.S. Department of Commerce—National Institute of Standards and Technology, 100 Bureau Drive, Gaithersburg, MD 20899. *Instrument:* Electron Microscope, Model Quanta Series. *Manufacturer:* FEI Company, The Netherlands. *Intended Use:* The instrument is intended to be used to image, measure and characterize moisture containing, wet, biological, semiconductor, energetic materials, nano-materials and composites, explosive materials and other non-conductive non-vacuum compatible materials. *Application accepted by Commissioner of Customs:* March 30, 2007.

Docket Number: 07-015. *Applicant:* VA Puget Sound Health Care System, 1660 S. Columbian Way, Seattle, WA 98108. *Instrument:* Electron Microscope, Model JEM-1011. *Manufacturer:* JEOL, Ltd., Japan. *Intended Use:* The instrument is intended to be used to investigate cancer, atherosclerotic cardiovascular disease, diabetes, Alzheimer's disease and other pathologic processes commonly diagnosed in veterans. Electron microscopy specimens will include tissues and cells from humans or experimental animal models.

Application accepted by Commissioner of Customs: March 28, 2007.

Docket Number: 07-018. *Applicant:* Virginia Polytechnic Institute and State University, Institute for Critical Technology and Applied Science, 1880 Pratt Drive, MC 0493, Blacksburg, VA 24061. *Instrument:* Electron Microscope, Model Quanta 600 FEG. *Manufacturer:* FEI Company, Brno, Czech Republic. *Intended Use:* The instrument is intended to be used to investigate biological samples, hydrated materials, and other specimens that have a high vapor pressure. As a part of a campus-wide, open user facility, it will be used in basic research studies of organic, inorganic, natural and synthetic materials (e.g. metals, ceramics, minerals, electronic materials, polymers, bio-materials). *Application accepted by Commissioner of Customs:* March 30, 2007.

Docket Number: 07-019. *Applicant:* University of Utah, Department of Ophthalmology & Visual Sciences, John A. Moran Eye Center, 65 Medical Drive, Salt Lake City, UT 84132. *Instrument:* Electron Microscope, Model JEM-1400. *Manufacturer:* JEOL Ltd., Japan. *Intended Use:* The instrument is intended to be used to generate a complete network map of the mammalian retina, against which changes triggered by disease or experimental intervention can be gauged. This work has taken on new importance as inherited or acquired retinal degenerations are now known to heavily impact retinal wiring and neuronal survival. *Application accepted by Commissioner of Customs:* April 2, 2007.

Docket Number: 07-020. *Applicant:* University of Rhode Island, Department of Chemical Engineering, 219 Morrill Science Building, Kingston, RI 02881. *Instrument:* Electron Microscope, Model JEM-2100. *Manufacturer:* JEOL, Ltd., Japan. *Intended Use:* The instrument is intended to be used to study soft and hard nanoscale materials. The properties of the materials and phenomena to be investigated are size, shape and composition. *Application accepted by Commissioner of Customs:* April 9, 2007.

Docket Number: 07-021. *Applicant:* The University of Texas at Austin, Purchasing Office, 2200 Comal Street, Austin, TX 78722. *Instrument:* Electron Microscope, Model JEM-1400. *Manufacturer:* JEOL Ltd., Japan. *Intended Use:* The instrument is intended to be used for several different types of experiments which will be aimed at understanding the structural basis of learning and memory and/or neuropathological conditions. These

experiments include electrophysiology, molecular biology, pharmacology, and behavioral tests to learn how brain structure is altered as a function of associated changes with each of these manipulations. *Application accepted by Commissioner of Customs: April 11, 2007.*

Docket Number: 07-022. Applicant: Duke University, Box 90271, Durham, NC 27708-0271. *Instrument:* Electron Microscope. *Manufacturer:* FEI Company, The Netherlands. *Intended Use:* The instrument is intended to be used to discover and quantify the structure and dimension of materials and biological samples, and then gain an understanding of how this structure determines or influences the properties or behaviors of the material or biological entity. *Application accepted by Commissioner of Customs: April 6, 2007.*

Faye Robinson,

Director, Statutory Import Programs Staff.
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DEPARTMENT OF COMMERCE

International Trade Administration

Applications for Duty-Free Entry of Scientific Instruments

Pursuant to Section 6(c) of the Educational, Scientific and Cultural Materials Importation Act of 1966 (Pub. L. 89-651; 80 Stat. 897; 15 CFR part 301), we invite comments on the question of whether instruments of equivalent scientific value, for the purposes for which the instruments shown below are intended to be used, are being manufactured in the United States.

Comments must comply with 15 CFR 301.5(a)(3) and (4) of the regulations and be filed within 20 days with the Statutory Import Programs Staff, U.S. Department of Commerce, Washington, DC 20230. Applications may be examined between 8:30 a.m. and 5 p.m. at the U.S. Department of Commerce, Room 2104, 14th and Constitution Ave., NW., Washington, DC.

Docket Number: 06-054. Applicant: Purdue University, 465 Northwestern Ave., West Lafayette, IN 47907-2035. *Instrument:* DBF Fiber Laser System. *Manufacturer:* Koheras A/S, Denmark. *Intended Use:* The instrument is intended to be used to study and formulate the physical description of the fundamental noise properties of optical frequency combs and their application to Optical Arbitrary Waveform Generation. An ultra-narrow

(1 kHz optical linewidth) CW laser is needed to sweep the carrier frequency and beat it with a conventional mode-locked laser based optical frequency comb. The CW laser also provides a 60 pm fast piezo tuning range and 700 pm thermal tuning with 100 mW output power. *Application accepted by Commissioner of Customs: September 1, 2006.*

Docket Number: 06-059. Applicant: Rutgers University, 3 Rutgers Plaza, Brunswick, NJ 08901-8559. *Instrument:* Micro-dissecting Microscope. *Manufacturer:* Singer Instruments, UK. *Intended Use:* The instrument is intended to be used to identify and categorize genes that control DNA replication and repair using a simple model organism known as baker's yeast. Strains of yeast-bearing mutations in genes that control the repair of damage in DNA and their genetic pathway will be studied. The instrument is a motorized micromanipulator specifically designed to separate single aspo-spores of yeast. It will also be used for student instruction in these areas. *Application accepted by Commissioner of Customs: October 19, 2006.*

Docket Number: 06-067. Applicant: The University of Illinois, 212 Tech Plaza, 616 East Green St., Champaign, IL 61820. *Instrument:* Ti: Sapphire Lasers (2), Model TIS-SF-077s. *Manufacturer:* Tekhnoscan, Russia. *Intended Use:* The lasers are intended to be used to study the application of ultra-cold atom gases to quantum simulation. They will be used to create an optical lattice, and part of a system for driving stimulated Raman transitions which will be integrated into a complex experimental apparatus requiring a CW, single-frequency, tunable Ti: sapphire ring laser with linewidth < 100 kHz, drift rate < 50 MHz/hour, locked to an external reference cavity, and completely reconfigurable for phase-locking optics and electronics with low drift rates since they will not be locked to a spectroscopic reference. *Application accepted by Commissioner of Customs: November 20, 2006.*

Docket Number: 07-005. Applicant: Millersville University, Physics Department, P.O. Box 1002, Millersville PA 17551. *Instrument:* HeNe Laser Cavity Educational Kit, Model CA-1200. *Manufacturer:* MICOS GmbH, Germany. *Intended Use:* The instrument is intended to be used in the lab portion of a course on optics for instruction on the physical principles and the components of a laser. Students will use the kit to build a He-Ne Laser themselves and study the role of different optical elements in the lasing

effect. Lab studies will include intensity distribution, Gaussian beam, polarization, divergence, coherence monochromatism and other properties of light. *Application accepted by Commissioner of Customs: January 17, 2007.*

Docket Number: 07-007. Applicant: Illinois Institute of Technology, 10 W. 33rd St., Room 224, Chicago, IL 60616. *Instrument:* High Temperature Nano Test System. *Manufacturer:* Micro Materials, Ltd., UK. *Intended Use:* The instrument is intended to be used to assess the mechanical properties of Ni-base alloys at elevated temperatures. Nano indentation tests will be conducted on the specimens at a range of temperatures from room temperature to 750 C to assess the hardness and modulus of the Ni-base alloys. These tests will permit evaluation of the characteristic mechanical properties of the constituent phases present in experimental Ni-base alloys and contribute to the development of new high temperature materials. The instrument requires a unique, horizontally-designed pendulum indenter to allow testing of specimens at temperatures in excess of 750 C. *Application accepted by Commissioner of Customs: January 23, 2007.*

Docket Number: 07-0011. Applicant: State University of New York, Stony Brook University, Stony Brook, NY 11794. *Instrument:* Low-level Beta Multicounter System. *Manufacturer:* Riso National Laboratory, Denmark. *Intended Use:* The instrument is intended to be used to measure emissions from very small quantities of naturally occurring, dissolved radioactive isotopes of thorium and lead in seawater which are attached to particulate matter in very small quantities. Samples of the isotopes are taken at various depths and serve as tracers of the movement of carbon to the deep, an important process that affects the biological cycle of the ocean as well as the carbon content of the atmosphere and is important for understanding climate change. The instrument will also be used for graduate education. This is the only beta detector that meets the requirements of five simultaneous measurements with extremely low background count rates of 0.2 cpm. It is also capable of field use in harsh environments. *Application accepted by Commissioner of Customs: February 23, 2007.*

Docket Number: 07-012. Applicant: University of Wisconsin, 750 University Ave., Madison, WI 53706-1490. *Instrument:* Real-time 3D Motion Capture System. *Manufacturer:* Phoenix